

Atty. Dkt. No. APPM/001717.D2/PPC/ECP/CKIM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chen, et al.

**Serial No.: 10/611,589**

Confirmation No.: 5241

Filed: June 30, 2003

For: Method and Apparatus for  
Annealing Copper Films

Group Art Unit: 1742

Examiner: George P. Wyszomierski

**MAIL STOP AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Dear Sir:**

**CERTIFICATE OF MAILING**  
**37 CFR 1.8**

I hereby certify that this correspondence is being deposited on  
9/30, 2005 with the United States Postal Service as  
First Class Mail in an envelope addressed to: Mail Stop  
Amendment, Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450.

9/30/05 *Ken Z. Z...*  
Date Signature

**RESPONSE TO OFFICE ACTION DATED MAY 31, 2005**

In response to the Office Action dated May 31, 2005, having a shortened statutory period for response extended one month to and including September 30, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Authorization to charge counsel's Deposit Account for the one month extension fee is given in a separate fee transmittal. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/001717.D2/KMT for any other fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 4 of this paper.